Electronic Patent Application Fee Transmittal							
Application Number:	10647247						
Filing Date:	26-Aug-2003						
Title of Invention:	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, AND METHOD OF FORMING RESIST PATTERN						
First Named Inventor/Applicant Name:	Hajime Yamamoto						
Filer:	Andrew G. Melick/Anita Plummer						
Attorney Docket Number:	031029						
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Basic Filing:							
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Miscellaneous-Filing:							
Petition:							
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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